



AF EFW

AMENDMENT TRANSMITTAL LETTER			Docket No. 30521/071	
Application No. 09/910,110-Conf. #1681	Filing Date July 20, 2001	Examiner H. D. Le	Art Unit 2643	

Applicant(s): Peter V. Loeppert et al.

Invention: RAISED MICROSTRUCTURE OF SILICON BASED DEVICE

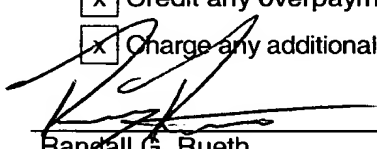
TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment after final in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	23	- 23 =		X	
Independent Claims	3	- 3 =		X	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00

- ☒ Large Entity ☐ Small Entity
- ☒ No additional fee is required for this amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of \$ _____.
A duplicate copy of this sheet is enclosed.
- ☐ A check in the amount of \$ _____ to cover the filing fee is enclosed.
- ☐ Payment by credit card. Form PTO-2038 is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. 13-2855
as described below. A duplicate copy of this sheet is enclosed.
- ☒ Credit any overpayment.
- ☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

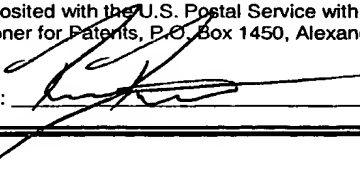

Randall G. Rueth
Attorney Reg. No.: 45,887

Dated: January 3, 2005

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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: January 3, 2005

Signature:  (Randall G. Rueth)



**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant: LOEPPERT ET AL.

Serial No.: 09/910,110

Filed: JULY 20, 2001

Title: RAISED MICROSTRUCTURE OF
SILICON BASED DEVICE

Group Art Unit: 2643

Examiner: HUYEN D. LE

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) 
) _____
) Randall G. Rueth
) Reg. No. 45,887

**AFTER FINAL RESPONSE TO THE ACTION
DATED NOVEMBER 3, 2004**

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the Final action dated November 3, 2004. Applicants respectfully request reconsideration of the application in view of the following amendments and remarks.

Status of the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.